

AF 2881

AMENDMENT TRANSMITTAL LETTER (Large Entity)

Applicant(s): **Ferrera et al.**

Docket No.

00750430AA

Serial No.
09/809,766

Filing Date
03/15/2001

Examiner
P. Gurzo

Group Art Unit
2881

Invention: **SPATIAL PHASE LOCKING WITH SHAPED ELECTRON BEAM LITHOGRAPHY**

TO THE COMMISSIONER FOR PATENTS:

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Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED

	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	20 -	20 =	0 x	\$18.00	\$0.00
INDEP. CLAIMS	3 -	3 =	0 x	\$86.00	\$0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0.00

- ☒ No additional fee is required for amendment.
- ☐ Please charge Deposit Account No. _____ in the amount of _____
- ☐ A check in the amount of _____ to cover the filing fee is enclosed.
- ☒ The Director is hereby authorized to charge payment of the following fees associated with the communication or credit any overpayment to Deposit Account No. **09-0458**
- ☒ Any additional filing fees required under 37 C.F.R. 1.16.
- ☒ Any patent application processing fees under 37 CFR 1.17.

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Dated: **January 21, 2004**

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FIS9-2000-0237US1 (00750430AA)

PATENT APPLICATION
BOX "AF"

RESPONSE UNDER 37 C.F.R. § 1.116
---EXPEDITE PROCEDURE---
EXAMINING GROUP 2881

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Juan Ferrera et al.

Confirmation No.: 4985

Serial No.: 09/809,766

Group Art Unit: 2881

Filed: March 15, 2001

Examiner: P. Gurzo

For: SPATIAL PHASE LOCKING WITH SHAPED ELECTRON BEAM
LITHOGRAPHY

Commissioner for Patents
United States Patent and Trademark Office
P. O. Box 1450
Alexandria, Virginia 22313-1450

REQUEST FOR RECONSIDERATION UNDER 37 C. F. R. §1.116

Sir:

In response to the Office Action mailed October 21, 2003, please reconsider the above-identified application in view of the following remarks

No amendments to the specification are
presented in this paper.

No amendments to the claims are presented in
this paper. A full listing of claims
begins on page 2 of this paper.

Remarks begin on page 6 of this paper.

